

Silicon Microcalorimeters for X-ray Spectroscopy – Status and Perspectives

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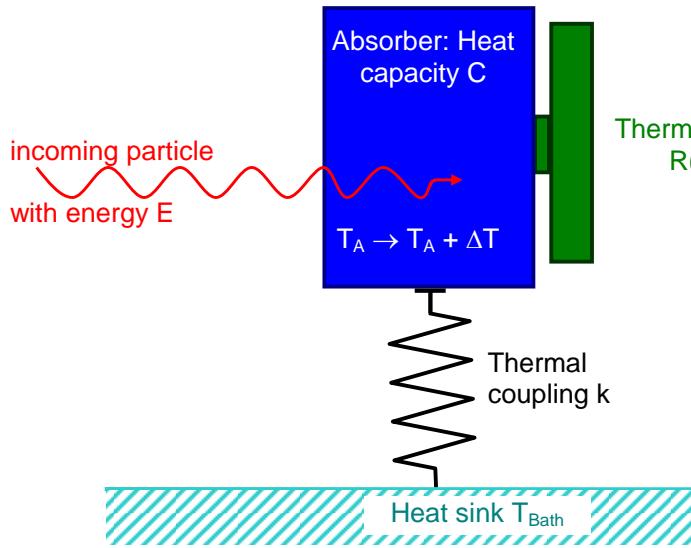
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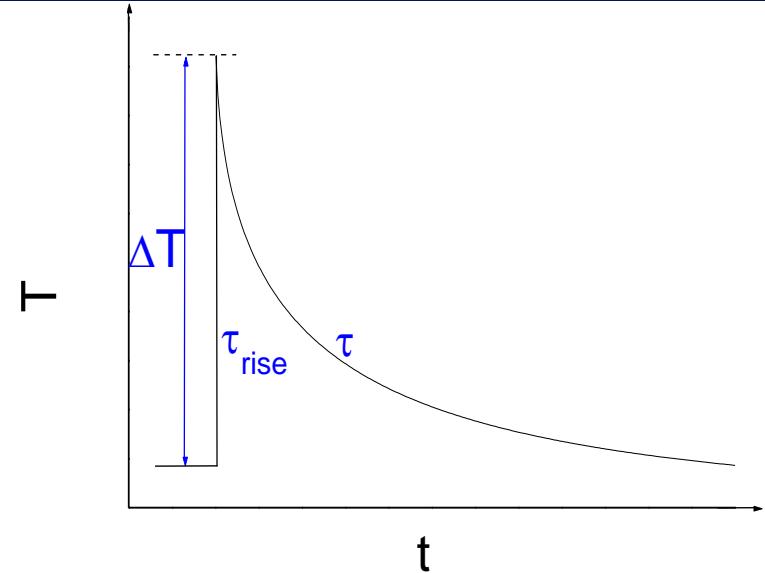


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Detection Principle of Microcalorimeters



$$C \cdot \frac{dT}{dt} = E \cdot \delta(t) - k \cdot T(t) + \frac{dR}{dT} I^2 T(t)$$



$$T(t) = \frac{E}{C} \cdot \left[\exp\left(-\frac{t}{\tau}\right) - \exp\left(-\frac{t}{\tau_{\text{rise}}}\right) \right]$$

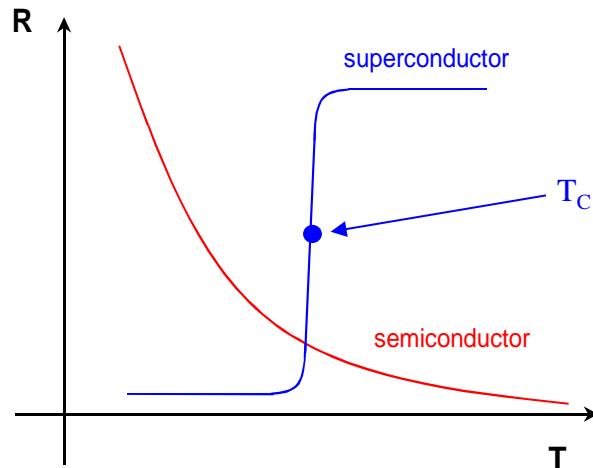
- Rise time τ_{rise} determined by resistor/capacitance of thermometer
- Signal height $\Delta T = E/C$
- Decay time: $\tau = \frac{C}{k - \frac{dR}{dT} I^2}$: $100 \mu\text{s} - 10 \text{ ms}$

I. Motivation

Why Silicon Microcalorimeters?

Resistance Thermometer:

- resistance thermometer: $\Delta T \rightarrow \Delta R \rightarrow \Delta U$
 - for high sensitivity: high dR/dT
 - specially doped semiconductor (large dynamic range) or superconductor in phase transition (very high dR/dT)
- thermometer technology with the longest standing history, well established and reliable
- systematic effects different from magnetic microcalorimeters
 - two different yet comparable detector concepts
- simultaneous measurements with two cryostats and two microcalorimeter arrays advantageous



II. Silicon Microcalorimeters for X-rays

Energies 10 – 100 keV:

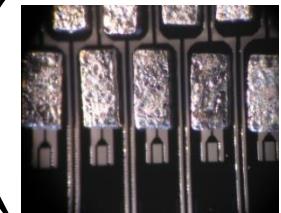
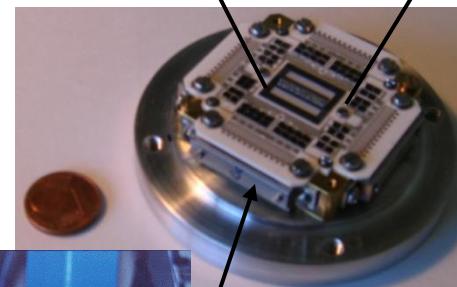
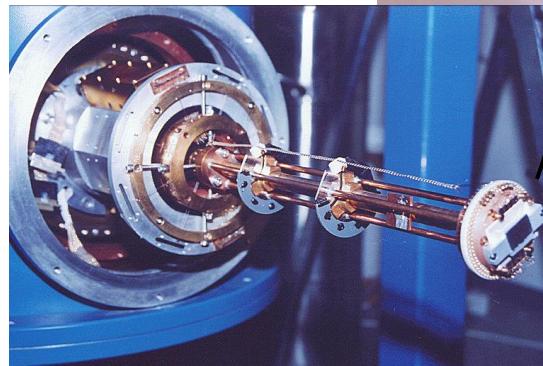
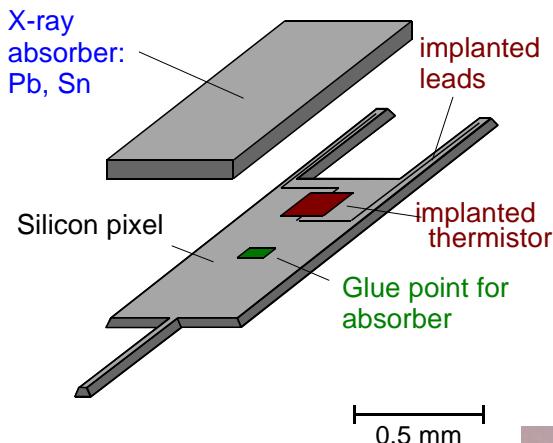
- $T_A \leq 60 \text{ mK}$

Absorbers:

- superconductors for small c
- high Z material
 - Pb, Sn
 - absorber thickness:
50 - 100 μm

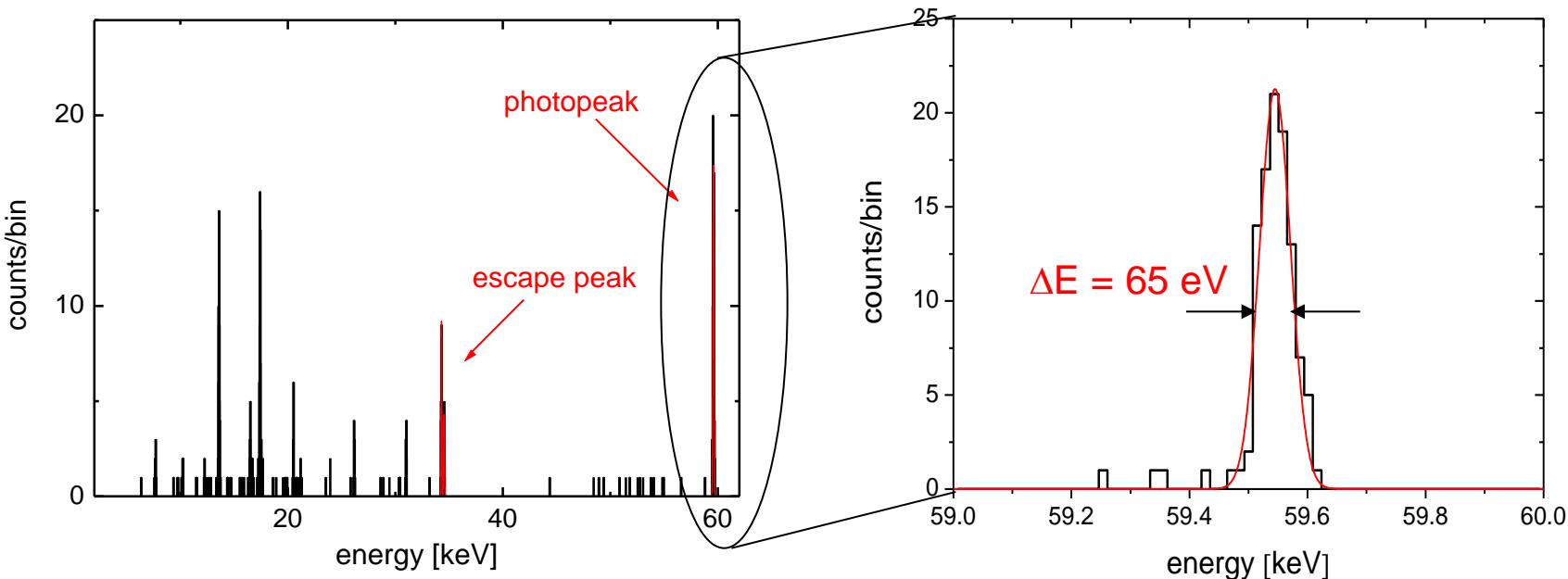
Thermistors:

- large energy range
 - Si doped with P and B
- 36 pixel detector array
 - pixel area $2 \times 0.5 \text{ mm}^2$
- developed and fabricated by Madison / Goddard and Mainz group
- (A. Bleile, J. Meier et al., AIP Conf. Proc. **605**, 2002)



Performance of Prototype Array: Energy Spectrum

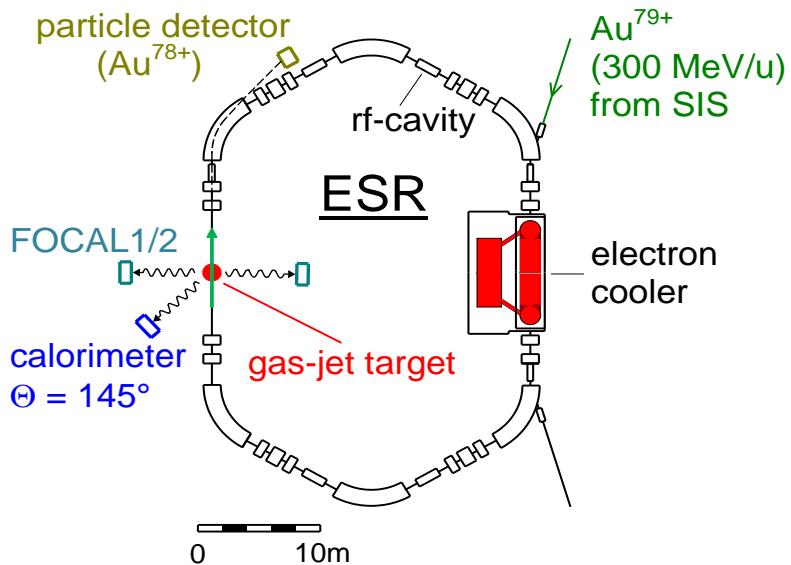
Energy spectrum obtained for a ^{241}Am source with an Sn absorber (0.3 mm 2 x 66 μm)



energy resolution at $E = 59.5 \text{ keV}$: $\Delta E = 60 - 65 \text{ eV}$ for Sn and Pb absorbers
for comparison:

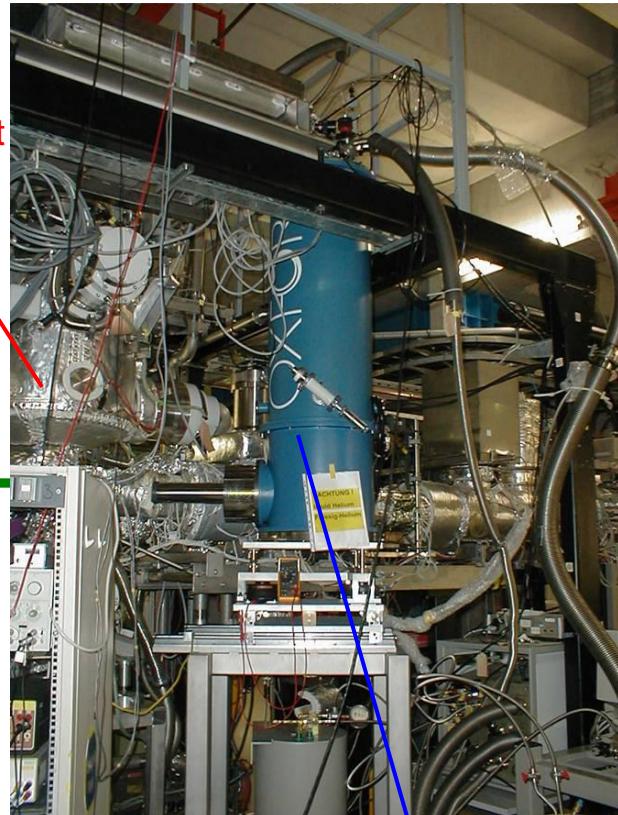
theoretical limit for a conventional semiconductor detector: $\Delta E_{\text{FWHM}} \approx 380 \text{ eV}$
(A. Bleile, J. Meier et al., AIP Conf. Proc. **605**, 2002)

III. First Application: The Lamb Shift Experiments at the ESR



gas jet target

- injection of fully stripped ions, beam cooling and deceleration
- electron capture in the gas target
- detection of the Lyman- α -radiation
- transformation of measured Lyman- α energy into laboratory frame
- joint experiments with crystal spectrometer FOCAL



Results

Two joint experiments with crystal spectrometer FOCAL

- beams: $^{207}\text{Pb}^{82+}$ at 219 MeV/u
 $^{197}\text{Au}^{78+}$ at 125 MeV/u

Doppler correction:

$$E_{emit} = E_{lab} \cdot \frac{1 - \beta \cos \Theta}{\sqrt{1 - \beta^2}}$$

→ angle Q and velocity β have to be known with high precision

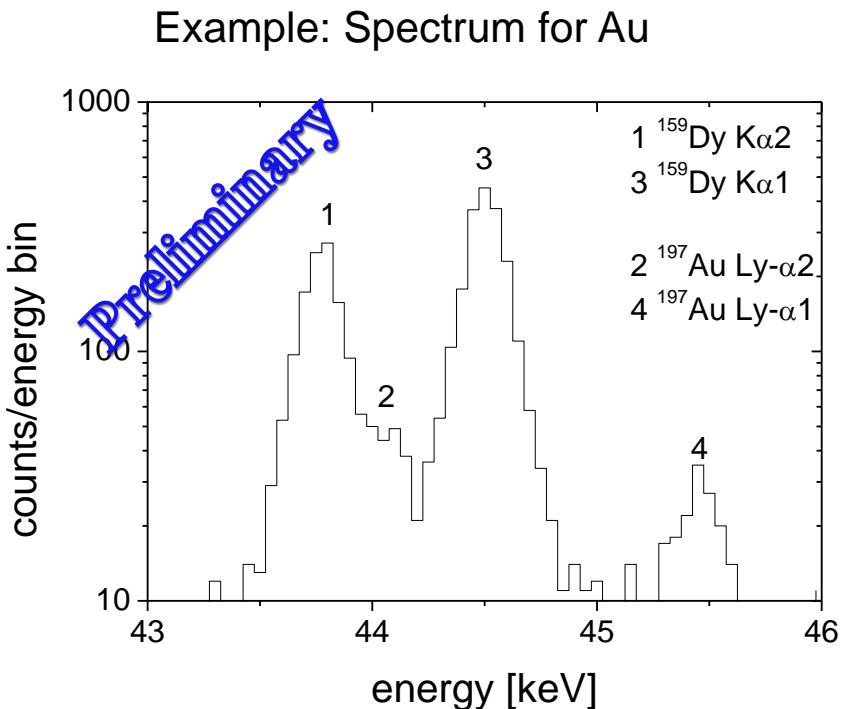
Preliminary Results:

$$E(\text{Ly-}\alpha 1) = (77919 \pm 6_{\text{stat}} \pm 17_{\text{syst}}) \text{ eV}$$

$$E(\text{Ly-}\alpha 1) = (71568 \pm 4_{\text{stat}} \pm 13_{\text{syst}}) \text{ eV}$$

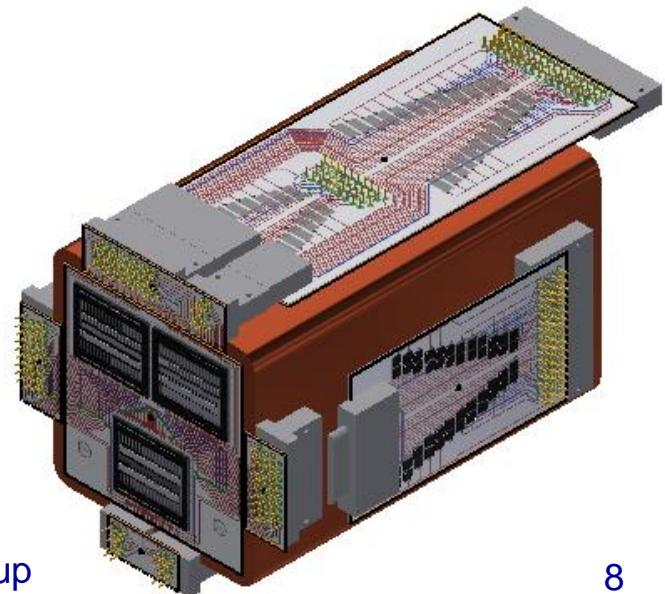
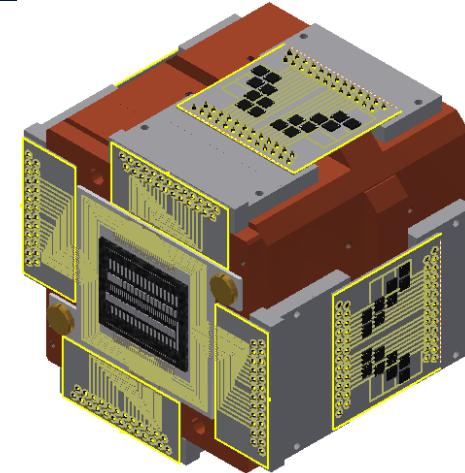
(S. Kraft-Bermuth et al., submitted to J. Phys. B, 2015)

- So far good agreement with theory (V. Yerokhin and V. Shabaev, Journal of Physical and Chemical Reference Data **44** (2015) 033103)
- systematic uncertainty dominated by precision of determination of Θ (9 eV)



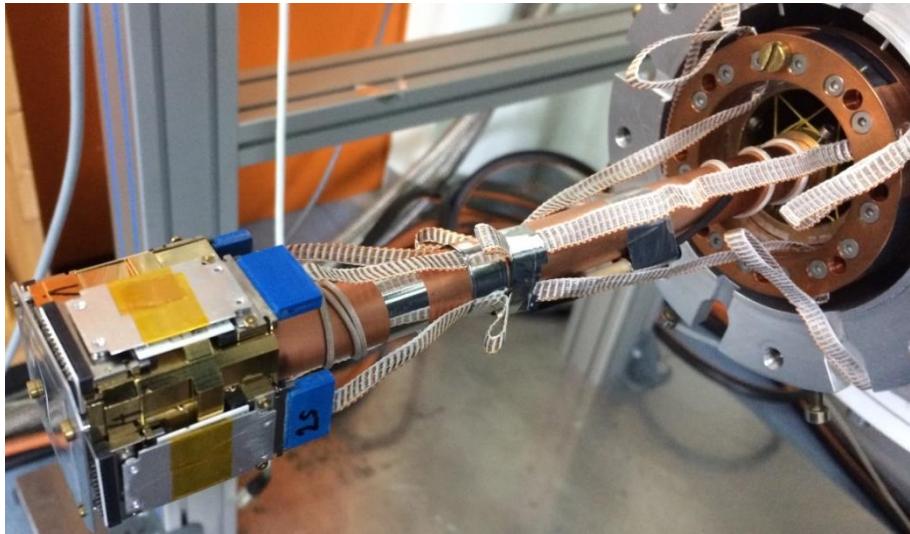
IV. New Detector Setup with 3 Arrays

- 1st step: test of a new, more compact design for 32 pixels
 - addition of low-energy pixels
 - separated load resistor boards
 - investigation of heat load and noise performance
 - tested in 2016 at ESR
- 2nd step: expand this design to $3 \times 32 = 96$ pixels
 - Parts in production
 - Assembly expected in 2017
- expand readout electronics and DAQ
 - new JFET boards based on standard PCBs: easy design and production
 - New DAQ program for 96 channels



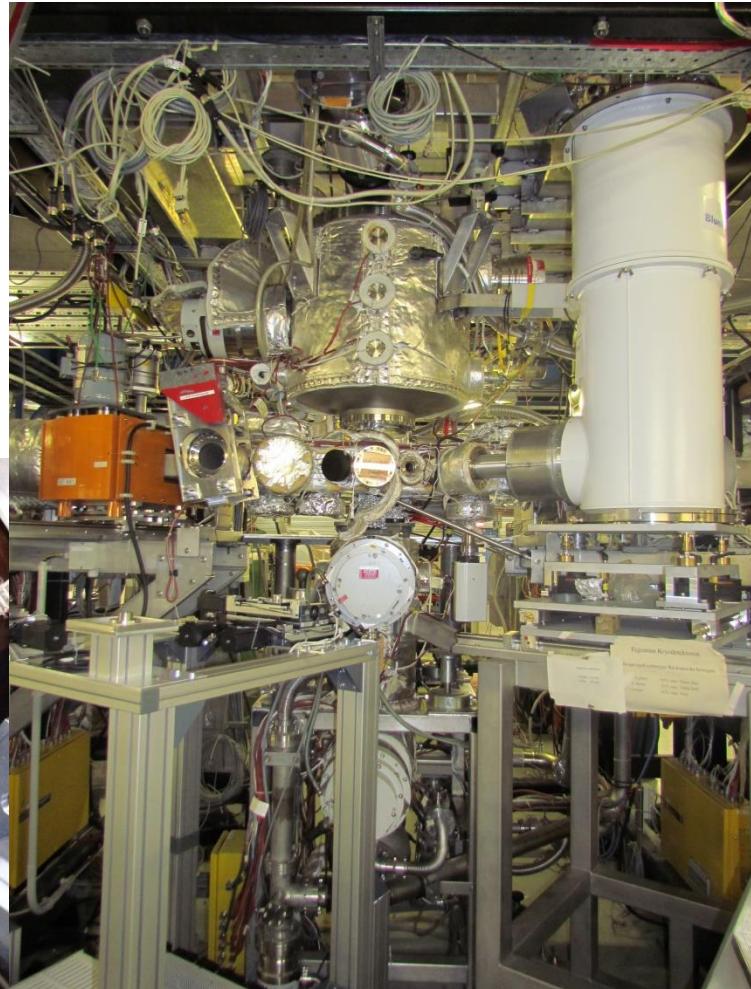
Tests at ESR 2016: Uranium

- 1st campaign: lithium-like uranium U^{89+} , $E = 70$ MeV/amu
 - Mostly low-energy X-ray transitions below 20 keV
 - Not optimal for our detector, which is optimized for $E \sim 100$ keV
 - Test of new design in laboratory very short
→ not optimized cryogenic setup

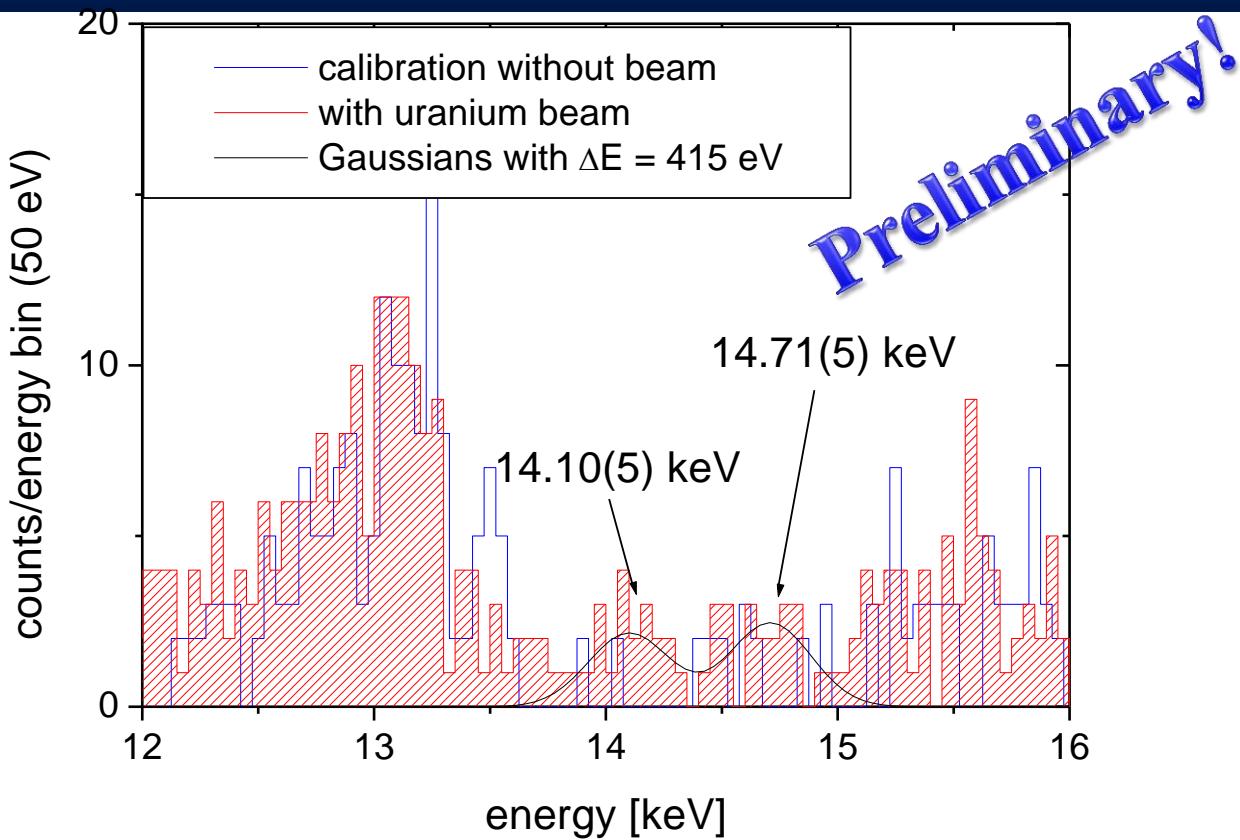


S. Kraft-Bermuth

The New Detector Setup



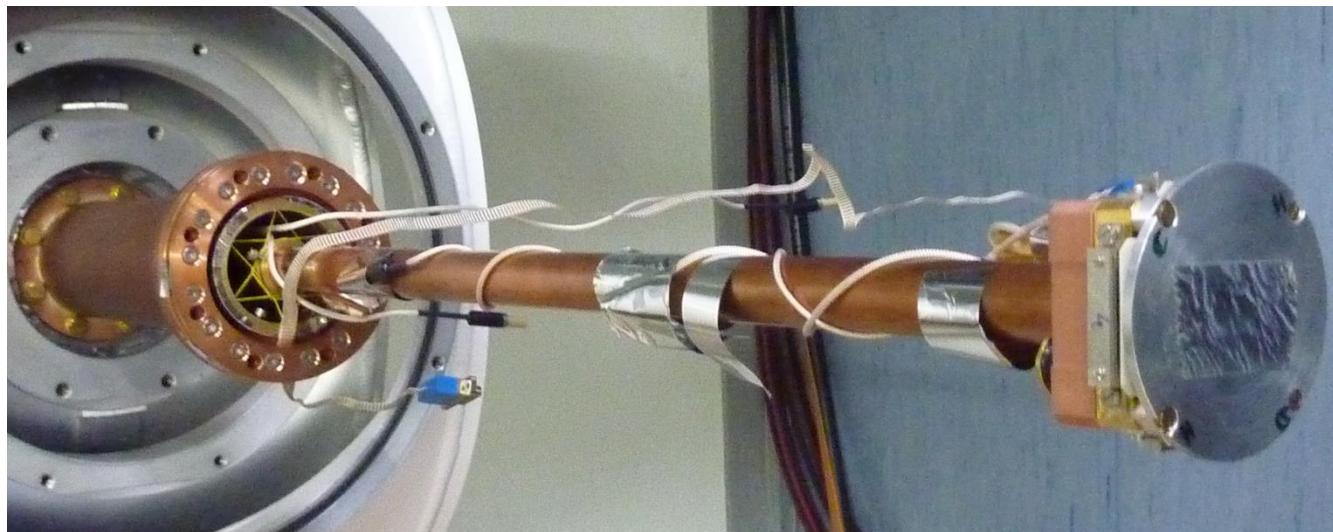
Tests at ESR 2016: Uranium



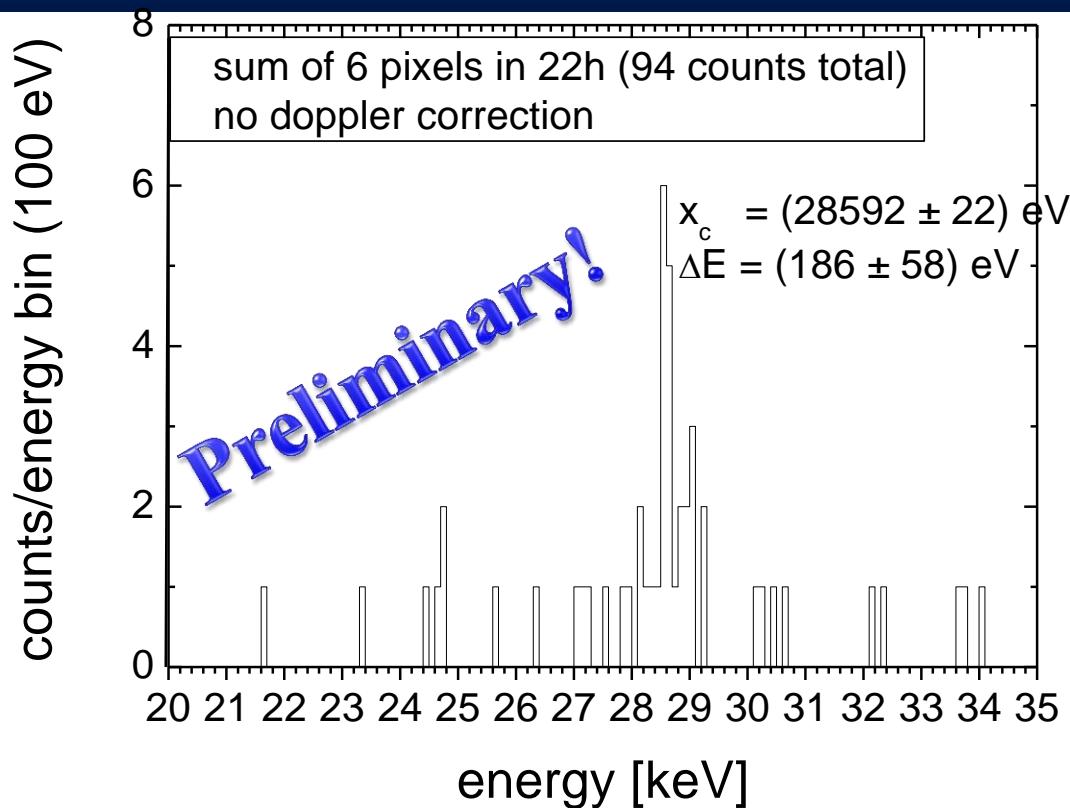
- Strong background from calibration sources
- Energy resolution around 400 eV @ 30 keV
- Main limitation: small signal amplitude due to bad thermal contact between detector and cryostat → currently under investigation

Tests at ESR 2016: Xenon

- 2nd campaign: hydrogen-like xenon Xe^{53+} , $E = 6 \text{ MeV/amu}$
 - X-ray energies $\sim 30 \text{ keV}$ (Lyman- α lines)
 - Count rate very low due to low ion energies (beam life time)
 - Used „old“ detector from Lamb Shift measurements in the new cryostat



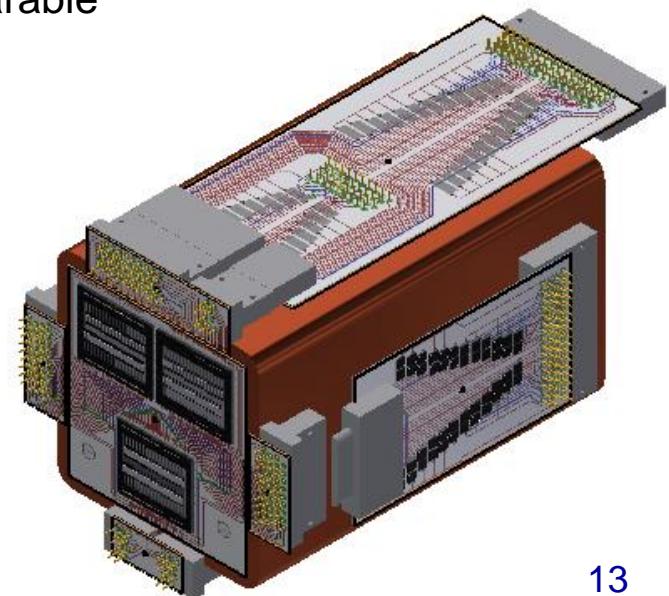
Tests at ESR 2016: Xenon



- Calibration sources removed, separate calibrations at beginning and end of run
 - Possible due to **very stable operation of cryostat (no temperature drifts)**
- Energy resolution ~ 200 eV (same as for Lamb Shift experiments)
- Analysis still in progress

V. Conclusion and Perspectives

- First test of SiM-X at ESR was successful
 - cryostat operated without problems at ESR for 7 weeks
 - maintained very stable operating temperature
 - ➔ measurements without permanent calibration possible
 - ➔ measurements at very low event rates for Xenon
- Performance of old „Lamb Shift“ detector array in new cryostat: $\Delta E \sim 200$ eV for 10 pixels (comparable to Lamb Shift measurements)
- Performance of new detector setup not yet comparable
 - cryogenic setup needs to be optimized
 - investigation in progress
- For larger array with 96 pixels
 - TDR approved end of last year
 - All parts are ready or in production
 - Assembly expected beginning of 2017
 - Ready to use in 2018 for experiments



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Thank you for your attention!